

FISCHERSCOPE® X-RAY SERIES

X-ray fluorescence for coating thickness measurement and material analysis



FISCHER TRUSTED BRANDS

GOLDSCOPE® FISCHERSCOPE®

MMS®

WinFTM®

XAN® XDAL®

XDLM®

XDV®

XULM®

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Helmut Fischer - Measuring Made Easy

The knowledge and willpower of our founder, Helmut Fischer—his inventive genius and irrepressible desire to implement—are the driving force behind an exemplary company development. In 1953, this success story began with the founding of a two-man company in Stuttgart, Germany. Today, Helmut Fischer is a global player at the forefront of industrial measurement technology.

Innovation and expertise

When it comes to surface measurements, we are state-of-the-art worldwide. Our vow is to continuously develop and produce technology-leading products that make our customers measurably more efficient. Our high-tech devices measure coating thicknesses down to the nanometer range and are used wherever precision, reliability and ease of use are required.

Customized product solutions

Our portfolio is diverse, with each solution perfectly matched to your requirements and wishes. Your big advantage: Fischer offers everything you need from one single source, whether simple handheld devices for quick measurements on the go, to XRF analysis, or fully integrated high-end systems for automated production monitoring.

Excellent customer service

With 21 subsidiaries worldwide and a large dealer network, we are there for our customers in almost every country. From the first joint consultation to your first self measurement, our experts from sales, application laboratory and service will ensure individual, fast and uncomplicated onsite support.

Quality and safety

If you assure quality in your products, then you should work with quality tools. For many decades, Helmut Fischer has stood for outstanding products at the highest level. Absolutely reliable measurement values—that is our promise to our customers. That is why we develop our measuring instruments in-house and produce most of them at our company headquarters in Germany. And we are certified according to ISO 9001.

Environment and sustainability

We stand for responsible and resource-saving actions while developing sustainable measurement solutions. With optimized processes and technologies, we reduce environmental impacts to a minimum. Whether recycling or upcycling, corresponding material and energy savings are not only to the benefit of the environment, but also of our customers.



The ambitious start

Helmut Fischer proudly looks back on a long and successful company history that began in 1953. At the age of only 22, Helmut Fischer founded the company "Schuhmann and Fischer" in a small workshop in Stuttgart, Germany, together with his mentor and former physics teacher Schuhmann.

The expansion

A few years later, Helmut Fischer founded the company of the same name with headquarters in Sindelfingen. Bolstered by the German economic miracle of the 1950s and 1960s, the Swabian one-man business became an international company.

The innovations

At the beginning of the 1980s, Fischer greatly expanded its product range. In 1982, the first X-ray fluorescence measuring instrument was launched. Thanks to many patented innovations, which still exist today, the instruments quickly established themselves in the industry. Further measuring and test instruments from the field of micro hardness and automated measuring solutions followed. Thanks to many patented innovations, which still exist today, the instruments quickly established themselves in the industrial environment.

The technical progress

We continue to succeed in developing market-leading measuring instruments by continuously improving the components used in order to support and encourage the technical progress of our customers. The extensive range of components ensures a high degree of customization.

The life's work

It has always been important to Helmut Fischer to build instruments that will last for many years. The company itself should be just as durable. Our declared goal is to develop measuring solutions that offer our customers added value and support them efficiently in the performance of their work. This focus shapes our work day after day.

The foundation

After five decades at its helm, Helmut Fischer transferred his company shares to the Helmut Fischer Foundation, which has ensured the continuity of the company and supported artists and young scientists since 2003.

The Fischer Advantage

Focus made by Fischer: As one of only two manufacturers of polycapillary optics in the world, we make it possible to focus a large part of the primary radiation onto a very small measuring spot

FOR EVERY REQUIREMENT THE RIGHT DEVICE SOLUTION

Detectors: You can choose from three different detector types for the optimal solution of your measurement task: proportional counter tube, silicon PIN diode and silicon drift detector

ELEMENT ANALYSIS UP TO 24 ELEMENTS SIMULTANEOUSLY

Particularly safe: Full-protection instruments in accordance with current radiation protection legislation

CALIBRATION EX WORKS

BUILT TO LAST: ROBUST CONSTRUCTION FOR PARTICULARLY HIGH DEMANDS



HIGHEST QUALITY – MADE IN GERMANY

Control panel: Proven and intuitive operating concept for easy handling of the instrument

Software: Most powerful application software for coating thickness measurement and material analysis on the market

MEASUREMENTS POSSIBLE FROM ABOVE, BELOW OR FLEXIBLE

Comprehensive service: From personal advice to preventive maintenance including repair and spare parts management to training at your site

THREE TABLE CONFIGURATIONS
AVAILABLE FOR YOUR NEEDS

X-ray tubes: Selection of different X-ray tubes for optimal measurements of your application

Many applications, a solution for everyone

Printed circuit boards: Our XRF systems comply with the IPC-4552-A/B and IPC-4556 standards. The measurement results are accurate and reproducible for the specified thickness range. HASL, electroless nickel and other critical coating systems can be measured quickly and accurately.

Applications: ENIG, ENEPIG, phosphorus content determination, solder alloys

Electronic components: Reliably control electronic components, such as compositions and layer thicknesses of lead-free solders during reflow soldering and analyses on SMD components.

Applications: Solder pads: Gold, silver, tin/tin alloy layers, under-nickel plating, palladium or palladium alloy layers

Lead frames: Determine the layer thickness and composition of complex multilayer coating systems on lead frames with repeatability and non-destructive accuracy. Applications: Thinnest gold, silver and palladium coatings, solder alloys

Large components: Our instruments offer you the possibility to measure large samples quickly and reliably.

Applications: Material analysis, zinc (nickel) on iron, chrome coating systems, electroless nickel on aluminum

Tools: Hard coatings only function efficiently as wear protection if the coating thickness, composition and surface hardness are correct. Testing instruments from Fischer use various methods, such as X-ray fluorescence, to precisely determine the coating thickness of TiN coatings and other hard metals or carbide coatings. Applications: Hard chrome, titanium nitride, titanium carbonitride, Titanium aluminum nitride, chromium nitride, zirconium nitride

Connector contacts: Functional surfaces on connector contacts from a size of approx. 20 µm can be measured precisely and non-destructively. These could be, for example, contact points, crimping surfaces or press-fit zones

Applications: (Hard) gold, silver, tin (alloy) layers, under-nickel plating, base material analysis

Metal finishing: Measure the coating thickness and composition of the corrosion protection layer non-destructively and reliable. Our instruments also determine the metal concentration in your electroplating bath easily and with high precision.

Applications: Zinc, copper, ZnNi, nickel, chromium, gold, palladium, rhodium, decorative surfaces

Semiconductor / Wafer: Clean room suitable, fast and precise XRF measuring instruments for layer thickness measurement and structural analysis of modern 2.5D-/3D-packaging solutions. The instruments are available as benchtop or fully automated.

Applications: Solder bumps, thin film metallizations, smallest structures

Jewelry: Whether in the watch industry, in the gold trade or in the jewelry sector – wherever precious metals are used, Fischer instruments have proven their worth thanks to non-destructive and highly precise measurements.

Applications: Silver, gold, palladium, platinum, nickel, titanium

Sanitary: Clear results in a short time: Precise measurement of all common multilayer systems. In our product portfolio of X-ray fluorescence analysis instruments, we have just the right instrument for you.

Applications: Chromium coating system, complex geometries, zinc die casting, copper alloys

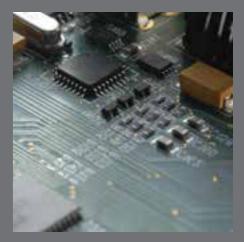
RoHS: Measuring instruments for the detection of lowest concentrations of heavy metals thanks to the sensitive silicon drift detectors. The measuring process is non-contact, non-destructive and simple. In addition, our measuring instruments offer a wide range of options for documenting the measurement results and generating reports. Our instruments measure quickly compared to chemical analysis and are excellent for screening.

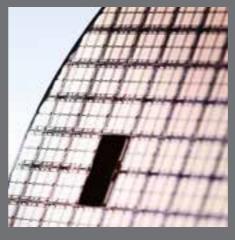
Decorative chromium coatings: To ensure that trim is visually flawless not only at delivery but also after years of use, the layer structure must be monitored with regard to the thicknesses of the individual layers.

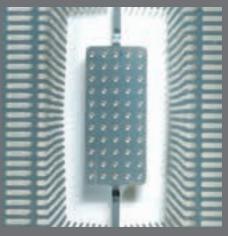
Applications: Decorative chrome coating systems on plastic substrates







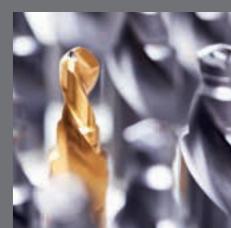




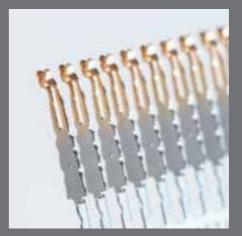














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ENVIRONMENT

UNIVERSAL MEASURING ENVIRONMENTS

- Production: Can be integrated in various production environments
- Clean room: Manufacturing under conditions of the clean room class 100
- Laboratory: Research, development, medical laboratories and pharma
- Quality assurance: Incoming goods inspection and process control
- In retail: Testing at the purchase of precious
- On site: Mobile use with portable measuring device indoors and outdoors





TAILOR-MADE: THE OPTIMAL INSTRUMENT SOLUTION FOR YOUR **APPLICATION**

- Handy X-ray fluorescence instruments
- Small benchtop instruments for places with little space
- Large instruments modularly scalable with plenty of space for your samples, for smallest measuring spots, (partial) automation possible
- Automated systems individually tailored to your requirements



MEASURING DIRECTION

ADVANTAGES OF THE DIFFERENT MEASURING DIRECTIONS



Top down

- autofocus possible
- Precise positioning
- Large measuring area



Bottom up

- Time saving since focusing is
- Optional with manual table



Flexible

- Measurement on very large components possible
- Most compact instrument
- Mobile measurements possible
- Battery operation



Fixed table

- Cost-effective
- Compact

SERVED UP



Manual XY table

- Simple and accurate positioning of the sample by hand
- Manual approach to multiple samples



Automatic XY table

- Controllable, also partially automated, via software
- Several samples can be measured in succession
- Automated image and pattern recognition via software
- Programming of measuring points, line or area scans



MEASURING TABLE





DIMENSION



THE RIGHT DETECTOR FOR EVERY APPLICATION

Proportional counter tube

- For coating thickness measurements and simple material analysis
- Very large active detector area for high count rates
- Insensitive to the sampleorientation and the measuring
- Ideal for complex shapes with recesses and different measur-



Silicon PIN diode (PIN)

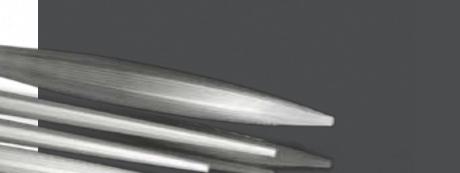
- For demanding coating thickness measurements and material analysis
- Ideal for measuring thin layers
- High energy resolution



Silicon drift detector (SDD)

- Measurement in the nanometer range and of complex multilayer
- Highest energy resolution and detection sensitivity
- Phosphorus determination of NiP coatings and RoHS screening
- Best for measurement of light elements (Al, Si, P, Cl)







- * Spot size: Full width at half maximum (FWHM) Mo-Kα
- The microfocus of the polycapillary optics amplifies the X-ray beam up to 10.000 times compared to collimator
- Instruments with polycapillary lenses are characterized by short measuring times when measuring smallest struc-
- Developed and produced in-house for best quality

HIGH INTENSITIES FOR SMALLEST **MEASURING SPOTS**



POLYCAPILLARY OPTICS



SOFTWARE

THE MOST COMPREHENSIVE SOFTWARE ON THE MARKET

- Universal software for coating thickness measurement as well as material and bath analysis

- Predefined measurement routines for standard
- Programming of complex measurement sequences including pattern recognition
- Data export to quality management systems
- Measuring equipment monitoring

- Statistical functions with statistical process control (SPC)
- Fully customizable reports and creation of individual measurement protocols



- Distance-dependent measured (DCM) value correction without additional calibrations
- Quick and convenient adjustment of the measuring distance, also stepless
- Measurements with the smallest possible distance and thus optimized counting rate
- Simple measurement of complex geometric shapes and in recesses
- Absolute safety: Switch-off plate and light barrier protect the detector from component collision – and thus your investment

SIMPLE AND QUICK ADJUSTMENT OF THE MEASURING DISTANCE





Product overview table

Measuring direction	View	Product family	Short characteristics
		XUL® 210/220	Robust model series for fast coating thickness measurement and determination of metal content of electroplating baths as well as the composition of simple alloy layers
<u> </u>		XULM® 240 PCB	Flexible measuring instruments for coating thickness measurement, also for filigree parts such as connectors, contacts or wires; special solution for printed circuit boards possible
Measuring bottom up		XAN® 215 220 / 222 250 / 252	Universal instruments for fast, precise metal and gold analysis, coating thickness measurement and RoHS screening (XAN® 250)
		GOLDSCOPE SD® 510 / 515 520 550	Special instruments for analysis and verification of gold and other precious metals
		GOLDSCOPE SD® 600	Special instrument for fast, cost-effective and non-destructive analysis of jewelry, coins and precious metals, also suitable for larger parts
		XDL® 210/220/230/240	Robust instruments for quality control of galvanized bulk parts and for bath analysis
		XDLM® 231/232/237/ PCB 220 PCB 200/210	Universal instruments for the inspection of small parts and small structures, for example in the electronics industry, for measurements of light metals, hard coatings and thin electroplated coatings; special solutions for printed circuit boards possible
		XDAL® 237 PCB	Model series for applications in the area of thin and very thin coatings; also for material analysis (e.g. RoHS screening); special solutions for printed circuit boards possible
<u>+</u>	- Canada	237 SDD	SDD version with high count rates for highest precision and shorter measuring times
Measuring top down		XDAL® 600	Easy-to-use and compact measuring instrument, specialized in the measurement of thin and very thin layers; also for material analysis (including RoHS screening)
		XDV°-SDD	Premium model for universal use – from inspection of very thin or complex layers to RoHS screening at very low detection limits
		XDV°-µ XDV°-µ PCB XDV°-µ WAFER XDV°-µ LD	Model series optimized for microanalysis for measurement on smallest components and structures; also for checking complex multilayer systems; special solutions for wafers, lead frames and printed circuit boards possible
↓ Mobile		XAN® 500	Flexible handheld instrument for precise coating thickness measurement and material analysis on bulky parts or in hard-to-reach places
		Customized solution and automation	Modular XRF benchtop instrument scalable, tailored to your requirements FISCHERSCOPE® X-RAY 5000 series, 4000 series and FISCHERSCOPE® XAN® LIQUID ANALYZER

 $^{^*}$ Standard size, optional sizes on request, ** Full width at half maximum (FWHM) (for Mo-K $_{\! \alpha}$)

Detector	Primary filter	Apertures	Aperture type/size *	C-slot	Page
Proportional counter tube	1	1	Ø 0.3 mm*	✓	18
Proportional counter tube	3	4	Ø 0.1 / 0.2 mm; 0.05 × 0.05 mm; 0.2 × 0.03 mm* Ø 0.1 mm* XULM® PCB: Ø 0.1 mm	✓ <u> </u>	18
PIN SDD SDD	- 1 6	1 1 4	Ø1 mm* Ø1 mm* Ø0.2/0.6/1/2 mm*	_	20
PIN SDD SDD	- 1 6	1 1 4	Ø1mm* Ø1mm* Ø0.2/0.6/1/2mm	_	22
SDD	3	4	Ø0.2/0.6/1/2mm*	_	24
Proportional counter tube	1	1	Ø 0.3 mm*	✓	26
Proportional counter tube	3	4	Ø 0.1 / 0.2 mm 0.05 × 0.05 mm; 0.2 × 0.03 mm* Ø 0.1 mm*	/	26 34 (PCB)
PIN SDD	3	4	Ø 0.1 / 0.3 / 0.6 mm 0.5 × 0.15 mm*	✓	28 36 (PCB)
SDD	3	4	Ø 0.1 / 0.3 / 1 / 3 mm*	_	24
SDD	6	4	Ø 0.2/0.6/1/3 mm*	_	30
SDD	4	Polycapillary optics	Ø 20 µm Standard** Ø 20 µm halofree** Ø 10 µm halofree** Ø 60 µm halofree**	/	32, 36, 38
SDD	1	1	Ø2mm	-	40
					42 - 49

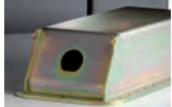
Let our experts advise you! sales@helmut-fischer.com

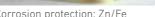




Entry-level model with a focus on speed

The instruments of the FISCHERSCOPE® X-RAY XUL® and XULM® series are the right solution for fast coating thickness determination in electroplating. There, a large number of samples must pass through quality control as efficiently as possible. For this reason, the XUL series is designed to enable bulky samples to be positioned manually in the measuring chamber. There is also the option of a manual XY stage, facilitating the exact alignment of small parts. An intuitive control panel on the front of the unit further simplifies handling.







The XUL® series allows measuring spots of 0.5 mm diameter. This makes the robust instruments perfect for measurements on nuts, screws and other galvanically finished surfaces. Many common applications for this instrument are in the corrosion protection industry. Connectors, contacts, wires and PCBs are the domain of the FISCHERSCOPE® X-RAY XULM® family.

- Robust entry-level instrument for coating thickness measurement and determination of metal content in electroplating baths
- XUL® set-up with bottom up measuring direction
- Standard X-ray tube (XUL®) or microfocus tube (XULM®)
- 4-fold changeable apertures (XULM®)
- 3-fold changeable filter (XULM®)
- Proportional counter tube detector for short measuring times, particularly large measuring distances and complex geometries
- Up to 17 cm sample height possible
- Fully protected instrument with type approval according to current radiation protection legislation

FISCHERSCOPE® X-RAY XAN®

Quick-measure design

The sample is placed and ready for measurement in just a few steps

Versatile: For trade, industry and laboratory applications

DPP+ digital pulse

processor: Shorter measuring times or improvement of standard deviation (not available with XAN® 215)

RoHS analysis: Reliable determination of hazardous substances

Commissioning

Extremely fast and simple





The system for a wide range of applications

The focus of the FISCHERSCOPE® X-RAY XAN® family is on fast and precise material analysis of precious metals and gold alloys. In addition, these instruments are used for the determination of heavy metal trace elements and other hazardous substances within the scope of the RoHS directive. This is particularly important for electronics and other manufacturing industries.

The XAN® 215 with a powerful PIN detector is suitable for analyzing simple gold alloys that contain only a few other elements such as silver and copper. For more complex alloys, instruments with a silicon drift detector (e.g. XAN® 220) are a better choice. With their much higher resolution, they can distinguish between gold and platinum, for example in the analysis of dental alloys and melted precious metal alloys.

RoHS screening also requires higher resolutions as well as different primary filters. Ideal for this: XAN® 250 with fixed sample support or the XAN® 252 with manually operated XY stage.



Adjusting the sample



Video image displays the measuring spot exactly

- Universal instrument for metal and precious metal analysis, coating thickness measurement on simple shaped samples and RoHS screening
- XAN form factor with measuring bottom up
- Microfocus tube with tungsten anode
- 4-fold changeable apertures (XAN® 250, 252)
- 6-fold changeable filter (XAN® 250, 252)
- Various semiconductor detectors ensure very good detection accuracy and high resolution: silicon PIN and silicon drift detector
- DPP+ digital pulse processor for higher count rates and significantly reduced measuring times
- Different measuring table options: fixed or manually operable
- Up to 17 cm sample height possible (XAN® 222, 252)
- Fully protected instrument with type approval according to current radiation protection legislation (XAN® 215, 220, 250)





Analysis, value determination and authenticity testing

With the GOLDSCOPE SD® family, Fischer offers tailored solutions for the non-destructive testing of gold and precious metals. All GOLDSCOPE SD® models are equipped with the WinFTM® software, which has the most important measuring tasks for the testing of gold and precious metals.

The GOLDSCOPE SD® family offers the right solution for your testing needs: Entry-level instruments with silicon PIN detectors are intended for use in stores and pawn-shops to check the composition of jewelry and dental gold. The GOLDSCOPE SD® 510 model is particularly space-saving: the laptop can be easily placed on top of the device.

For test laboratories and jewelry manufacturers, the series offers instruments with a silicon drift detector and changeable apertures. Thus, the GOLDSCOPE SD® family also meets sophisticated demands.

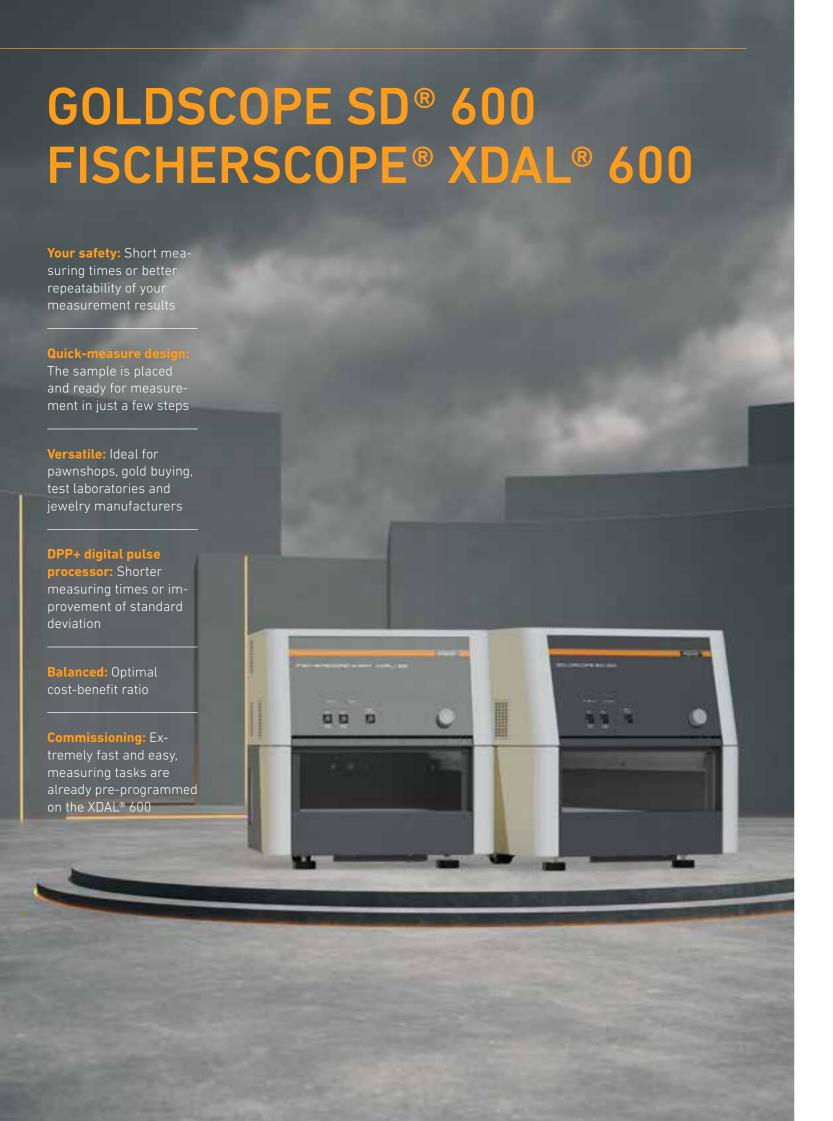


Authenticity testing

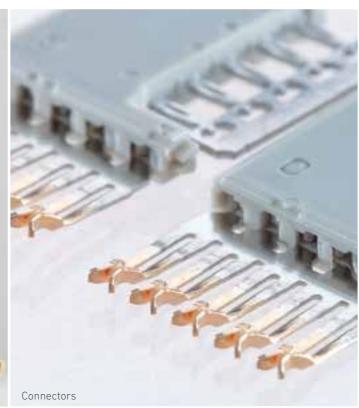


Determination of value

- Compact and robust benchtop instrument for fast, cost-effective and non-destructive analysis of jewelry, coins and precious metals
- Hardware and software aligned to measuring tasks related to gold and precious metals
- Especially space-saving with the GOLDSCOPE SD® 510 version
- Measuring direction with measuring bottom up
- 4-fold changeable apertures (GOLDSCOPE SD® 550)
- 6-fold changeable filter (GOLDSCOPE SD® 550)
- Various semiconductor detectors ensure very good detection accuracy and high resolution: silicon PIN and silicon drift detector
- DPP+ digital pulse processor for higher count rates and significantly reduced measuring times
- Fully protected instrument with type approval according to current radiation protection legislation







Analysis, value determination and authenticity testing

GOLDSCOPE SD® 600

The GOLDSCOPE SD® 600 is tailor-made for non-destructive gold and jewelry testing as well as precious metal analysis. Predefined measurement tasks (gold setup) simplify the application for you. The silicon drift detector ensures high-resolution analyses of alloys and layers such as gold on sterling silver or rhodium on gold alloys.

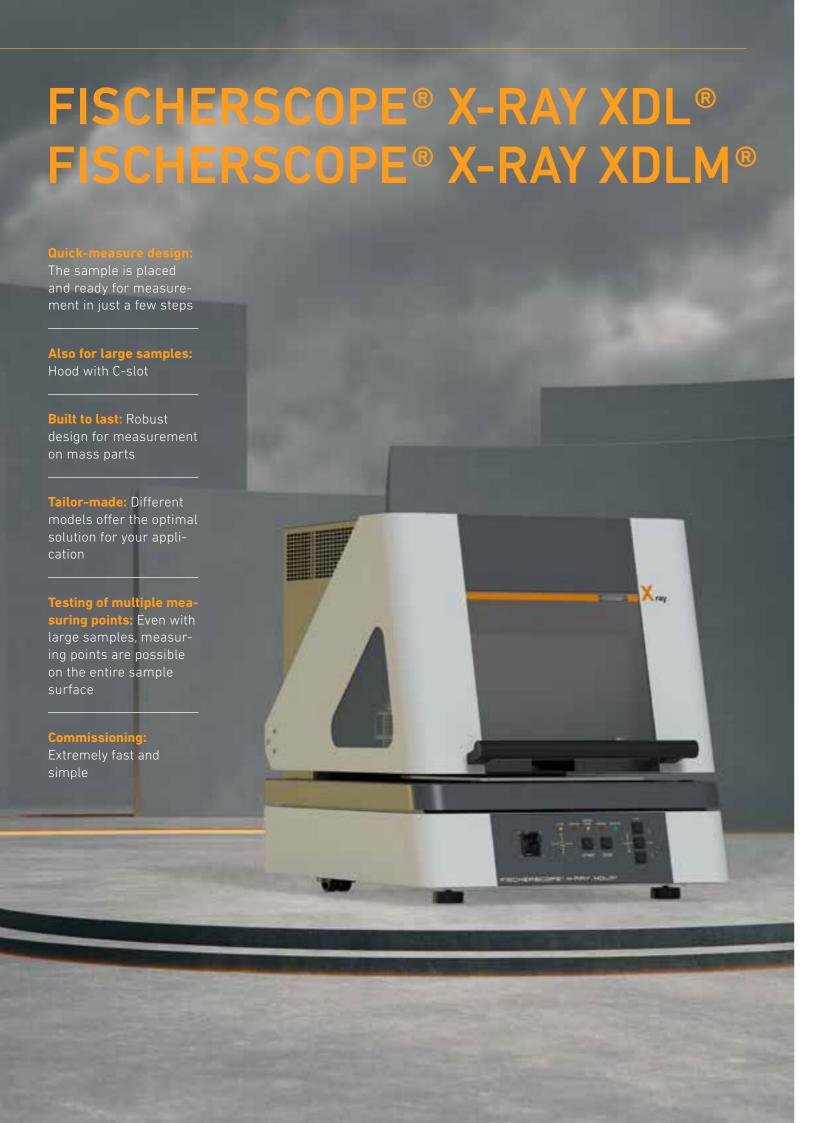
Features

- Robust benchtop instrument for analysis of jewelry, coins and precious metals
- Measuring direction with measuring top down
- Microfocus tube with tungsten anode
- 4-fold changeable apertures
- 3-fold changeable filter
- Silicon drift detector 20 mm² for highest precision on thin layers as well as peltier cooling
- DPP+ digital pulse processor for higher count rates and significantly reduced measurement times
- Manually adjustable sample stage for fast and easy sample positioning

FISCHERSCOPE® X-RAY XDAL® 600

The FISCHERSCOPE® X-RAY XDAL® 600 is designed for non-destructive measurement of very thin layers and material analysis. This instrument is characterized by its compact design, simple handling and operation with a silicon drift detector that allows for the highest performance.

- Universal instrument for measurement on smallest structures, very thin multilayers, functional layers and very thin coatings $\leq 0.1 \, \mu m$
- Measuring direction with measuring top down
- Microfocus tube with tungsten anode
- 4-fold changeable apertures
- 3-fold changeable filter
- Silicon drift detector 20 mm² for highest precision on thin layers as well as peltier cooling
- DPP+ digital pulse processor for higher count rates and significantly reduced measurement times
- Manually adjustable sample stage for fast and easy sample positioning





Your ticket into automated measurement

FISCHERSCOPE® X-RAY XDL® and XDLM® instruments are closely related to the XUL® and XULM® series. Detectors, X-ray tubes, apertures and filter combinations are identical. However, the XDL® and XDLM® measure top down.

The XDL® series, predestined for the control of mass-produced galvanized parts and bath analysis, ranges from single benchtop instruments (e.g. XDL® 210 and 220 with fixed sample support) to models with a programmable XY table (XDL® 240). The latter can be used for automated



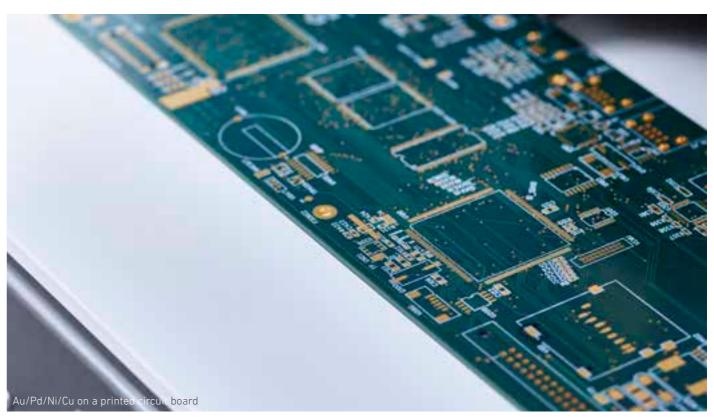


The XDLM® series differs from its sister series XDL® as it is equipped with a microfocus tube and changeable apertures and primary filters. It is the best choice for inspecting many small parts in succession. It is also very useful for the electronics industry.

The variable measuring distance of $0 - 80 \, \text{mm}$ facilitates measuring on irregularly shaped parts like connectors (e.g. XDLM® 237).

- Universal instrument for measurements on galvanic
- Stepless measuring distance with measuring top down
- Standard X-ray tube (XDL®); microfocus tube (XDLM®)
- 4-fold changeable apertures (XDLM®)
- 3-fold changeable filter (XDLM®)
- Proportional counter tube detector for short measuring times and small measuring spot
- Various measuring table options; models with extended sample support
- Fully protected instrument with type approval according to current radiation protection legislation





The best detectors for thin layers

With its semiconductor detectors and the programmable measuring table, the FISCHERSCOPE® X-RAY XDAL® series is an excellent choice for fast and accurate measurements of solder composition. This makes it possible to eliminate the risk of getting different solder batches via a simple scan at incoming goods inspection.

The XDAL® series is also well suited for applications that require testing thin and ultra-thin coatings < $0.05\,\mu m$. This allows, for example, expensive materials to be saved and process-reliable production to be carried out. Mass inspection of different components in production control and incoming goods can also be completed.

The instrument version with a 50 mm² silicon drift detector is suitable for RoHS measurements.



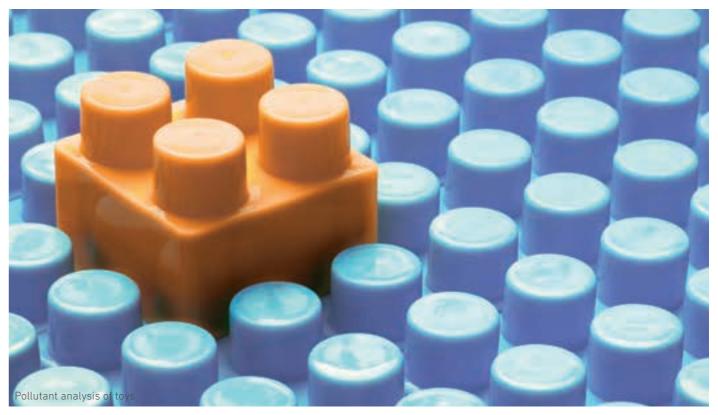
HSS drill bit: TiN/Fe



High reliability: Pb (> 3 %) electronic components

- Universal instrument for automated measurements of thin and very thin layers < 0.05 µm and for material analysis in the ppm range
- Stepless measuring distance with measuring top down
- Microfocus tube with tungsten anode
- 4-fold changeable apertures
- 3-fold changeable filter
- Various semiconductor detectors ensure very good detection accuracy and high resolution: silicon PIN and silicon drift detector
- Optionally also available with fixed or manual measuring table
- Fully protected instrument with type approval according to current radiation protection legislation





The high-end all-rounder

FISCHERSCOPE® X-RAY XDV®-SDD models are among the most powerful X-ray instruments. Their silicon drift detector is extremely sensitive to fluorescence radiation of light elements. This permits very low detection limits as well as measurement applications relating to NiP, RoHS and very thin layers < 0.05 µm. This is why the universal XDV®-SDD instrument performs exceedingly well in research and development, laboratory and process qualification settings. Also, its ease of use makes it indispensable in production control.



NiP/Fe: P concentration and layer thickness



Passivation layers: Cr/Zn/Fe

The XDV®-SDD system is especially well suited for precise trace analysis and rapid monitoring of pollutant limit values. For example, in plastics it can be used to determine critical chemical elements such as lead, mercury and cadmium with detection limits of just a few ppm.

- Universal instrument for the determination of pollutants in the smallest concentrations according to RoHS and for automated measurements of layers, including < 0.05 µm
- Stepless measuring distance with measuring top down
- Microfocus tube with tungsten anode
- 4-fold changeable apertures
- 6-fold changeable filter
- Silicon drift detector 50 mm² for highest precision on thin layers
- Aperture (collimator) up to 3 mm: Highest intensity for shortest measuring time even with difficult samples (thinnest coatings, Si wafers, conversion layers), light elements (fuel cells, Al components)
- Programmable measuring stage for automated measurements on small structures
- Fully protected instrument with type approval according to current radiation protection legislation

FISCHERSCOPE® X-RAY XDV®-µ FISCHERSCOPE® X-RAY XDV®-µ LD

Meeting all challenges

Reliable and fast results for ambitious measurement

DPP+ digital puls

processor: Shorter measuring times or improvement of standard deviation

Most advanced polycapillary optics on the market: Our in-house manufactured polycapillary optics deliver outstanding measurement results with short measuring times

Fully automatable: Let your instrument work for you with just one click

Your safety: Short measuring times or better repeatability of your measurement results

Accurate and precise:

Positioning of the measuring point on small structures thanks to automatic image reco-



The FISCHERSCOPE® X-RAY XDV®-µ instruments form Fischer's high-end X-ray fluorescence series, designed for precise coating thickness measurement and material analysis on tiny structures. The instruments are equipped with powerful silicon drift detectors and polycapillary optics, which drastically reduce measuring times and enable repeatable measurements due to the high radiation intensity.

The XDV®- μ instruments are used in particular for applications in the electronics and semiconductor industry such as the measurement of very small structures, e.g. bond surfaces, SMD components or thin wires.





SMD components

Lead frames

The roomy, easily accessible measuring chamber with side cut-outs (C-slot) and expanded sample support facilitates working with large samples.

The XDV®- μ LD model offers more space for complex shaped test parts with outstanding measurement performance.

The Long Distance capillary allows smallest measuring spots and exact measurements on assembled PCBs, connectors or pins at a unique measuring distance of 12 mm.

- Universal instrument for measurements on smallest components and structures as well as complex multilayer systems
- Stepless measuring distance with measuring top down
- Microfocus tube with tungsten anode; molybdenum anode optional
- 4-fold changeable filter
- Polycapillary optics permit particularly small measurement spots of 60 µm FWHM at short measuring times with high intensity
- Silicon drift detector 20 or 50 mm² for highest precision on thin layers
- Video system with 3x optical zoom for precise sample positioning
- Precise programmable measuring table for automated measurements on small structures

FISCHERSCOPE® X-RAY XULM®-PCB FISCHERSCOPE® X-RAY XDLM®-PCB

PCB experts: Specialized measuring solutions for printed circuit boards

Accurate and precis

Positioning of the measuring point on small structures thanks to automatic image recognition

Quick-measure design:

The sample is placed and ready for measure-ment in just a few simple steps

Tailor-made: Different models offer the optima solution for your application

Balanced: Optimal cost-benefit ratio

Commissioning: Extremely fast and



The entry-level series for printed circuit boards

FISCHERSCOPE® X-RAY XULM®-PCB

The PCB series was specially developed for the measurement and analysis of layer thicknesses on printed circuit boards. The FISCHERSCOPE® X-RAY XULM®-PCB is well suited for simple measuring tasks with a small measuring spot. The XRF spectrometer is equipped with a proportional counter tube detector which allows short measuring times due to its large detector area.

Features

- Robust entry-level instrument for simple measurements of components and structures on printed circuit boards
- Measuring direction with measuring bottom up
- Microfocus tube with tungsten anode
- Fixed aperture
- Fixed filter
- Proportional counter tube detector for short measuring times and small measuring spot
- Fixed, wide measuring table for printed circuit boards up to 610 × 610 mm, optionally with measuring table extension
- Fully protected instrument with type approval according to current radiation protection legislation

FISCHERSCOPE® X-RAY XDLM®-PCB

The FISCHERSCOPE® X-RAY XDLM® PCB with proportional counter tube is ideal for fast measurement of single measurement tasks with small measuring spot. The main difference between the model series: XDLM has additional functionalities for optimal measuring conditions and are suitable for automated measurements in production control (XDLM® PCB 210 and 220).

- Universal entry-level instrument for simple measurements of components and small structures on printed circuit boards
- Measuring direction with measuring top down
- Microfocus tube with tungsten anode
- Fixed or 4-fold changeable apertures
- Fixed or 3-fold changeable filter
- Proportional counter tube detector for short measuring times and small measuring spot
- Various measuring table options: manual pull-out, optional with measuring table extension or programmable, for PCBs up to 610 × 610 mm

FISCHERSCOPE® X-RAY XDAL®-PCB FISCHERSCOPE® X-RAY XDV-µ® PCB

Meeting all challenges

Reliable and fast results for ambitious measuring tasks

DPP+ digital pulse processor: Shorter measuring times or improvement of standard deviation (XD-V®-μ PCB)

PCB experts: Specialized measuring solutions for printed circuit boards, fulfill IPC standards

Most advanced polycapillary optics on the market: Our in-house manufactured polycapillary optics deliver outstanding measurement results in short measuring times (XDV®-µ PCB)

Fully automatable:

Let your instrument work for you

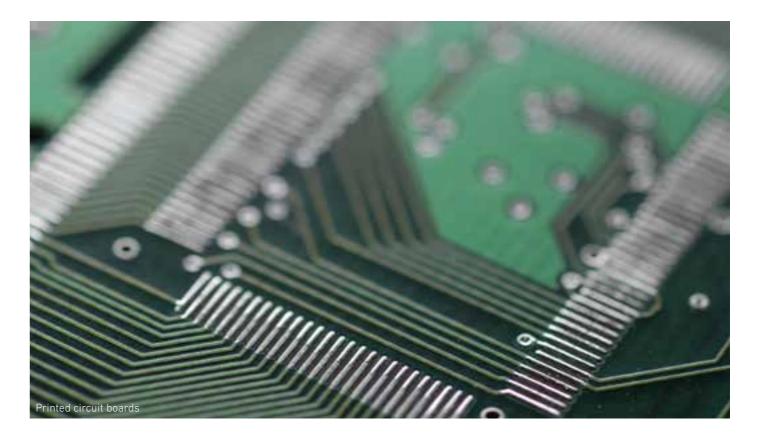
Accurate and precis

Positioning of the measuring point on small structures thanks to automatic image recog-

nition

Commissionir

Extremely fast and simple



The professional series for printed circuit boards

FISCHERSCOPE® X-RAY XDAL®-PCB

Due to the combination of a powerful silicon drift detector, multi-collimator and changeable filters, FISCHERSCOPE® X-RAY XDAL®-PCB instruments are predestined for the measurement of small structures on printed circuit boards. The instruments allow optimal measurement conditions for various applications, e.g. ENIG and ENEPIG.

Features

- Universal instrument for measurements on small structures, multilayers, functional layers and thin coatings < 0.1 µm
- Measuring direction with measuring top down
- Microfocus tube with tungsten anode
- 4-fold changeable apertures
- 3-fold changeable filter
- Silicon drift detector 20 or 50 mm² for highest precision on thin layers
- Various measuring table options: manual pull-out, optional with measuring table extension or automated, for PCBs up to 610 × 610 mm

FISCHERSCOPE® X-RAY XDV-μ® PCB

The FISCHERSCOPE® X-RAY XDV®- μ PCB instruments are used for measurements on smallest structures. Thanks to silicon drift detectors and polycapillary optics, the high-end instrument measures with extremely small measuring spot at very high intensity. The instruments meet the IPC requirements for ENIG and ENEPIG.

- Universal instrument for automated measurements on smallest structures, multilayers, functional coatings and very thin coatings < 0.1 µm
- Microfocus tube with tungsten anode; molybdenum anode optional
- Measuring direction with measuring top down
- 4-fold changeable filters
- Polycapillary optics permit particularly small measuring spots Ø approx. 20 or 10 µm
- Silicon drift detector 20 or 50 mm² for highest precision on thin layers
- Programmable measuring table for printed circuit boards up to 613 × 610 mm, optionally with vacuum function

FISCHERSCOPE® X-RAY XDV®-µ WAFER

Meeting all challenges:

Reliable and fast results for ambitious measuring tasks

DPP+ digital pulse processor: Shorter measuring times or improvement of standard deviation

Fully integrated solu-

tion: XDV®-μ SEMI combined with wafer handler of your choice

Most advanced polycapillary optics on the market: Our in-house manufactured polycapillary optics deliver outstanding measurement results at short measuring times

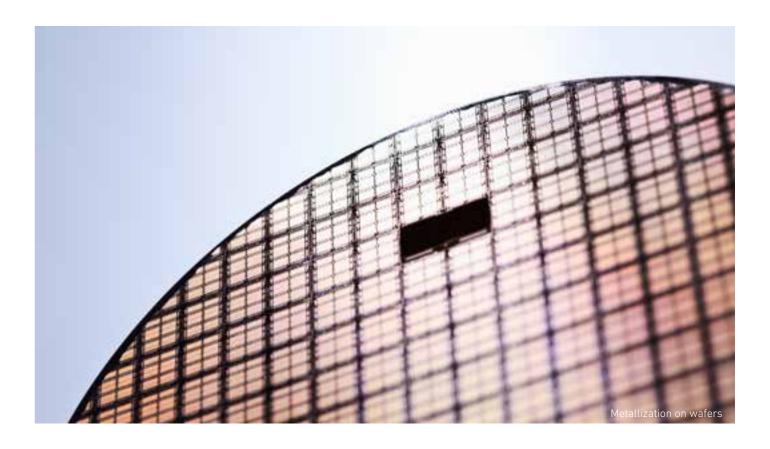
Fully automatable: Let your instrument work for you with just one click

Your safety: Short measuring times or better repeatability of your measurement results

Accurate and precise

Positioning of the measuring point on small structures thanks to automatic image recog





Cutting-edge technology for wafer applications

Wafers place some of the highest demands on the measurement technology used. Firstly, the surfaces are very sensitive. Secondly, the structures are so small that only special instruments can analyze them.

FISCHERSCOPE® X-RAY XDV®-µ WAFER models are designed specifically for automated analysis of microstructures and to meet the needs of the semiconductor industry. Typical measuring tasks include the characterization of base metallizations, material analysis of solder bumps and coating thickness measurement on contact surfaces.





Solder bumps

Small structures

Testing of such tiny structures requires minuscule measuring spots. That is why XDV®- μ WAFER instruments are equipped with polycapillary optics. They focus the X-ray onto a measuring spot of just 10 - 20 μm . A XDV®- μ WAFER system thus allows for much more precise characterization of the individual microstructures than any conventional instruments can.

- Special instrument for automated measurements of thin layers and multilayer systems on wafers with diameters from 6 - 12 inches
- Stepless measuring distance with measuring top down
- Microfocus tube with molybdenum anode; tungsten anode optional
- 4-fold changeable filter
- Polycapillary optics permit particularly small measuring spots of 10 or 20 µm FWHM at short measuring times with high intensity
- Silicon drift detector 20 mm² or 50 mm² for highest precision on thin layers
- Precise, programmable measuring table with vacuum wafer chuck for automated measurements on small structures





The specialist for field duty

Despite its small size, the FISCHERSCOPE® X-RAY XAN® 500 is in no way second to laboratory equipment. The modern silicon drift detector is capable of accurate and precise measurement results with short measuring times. Even complex measuring tasks involving multiple layers are performed reliably – and quickly. How? The compact device detects thickness and composition of the layer in a single measuring step.



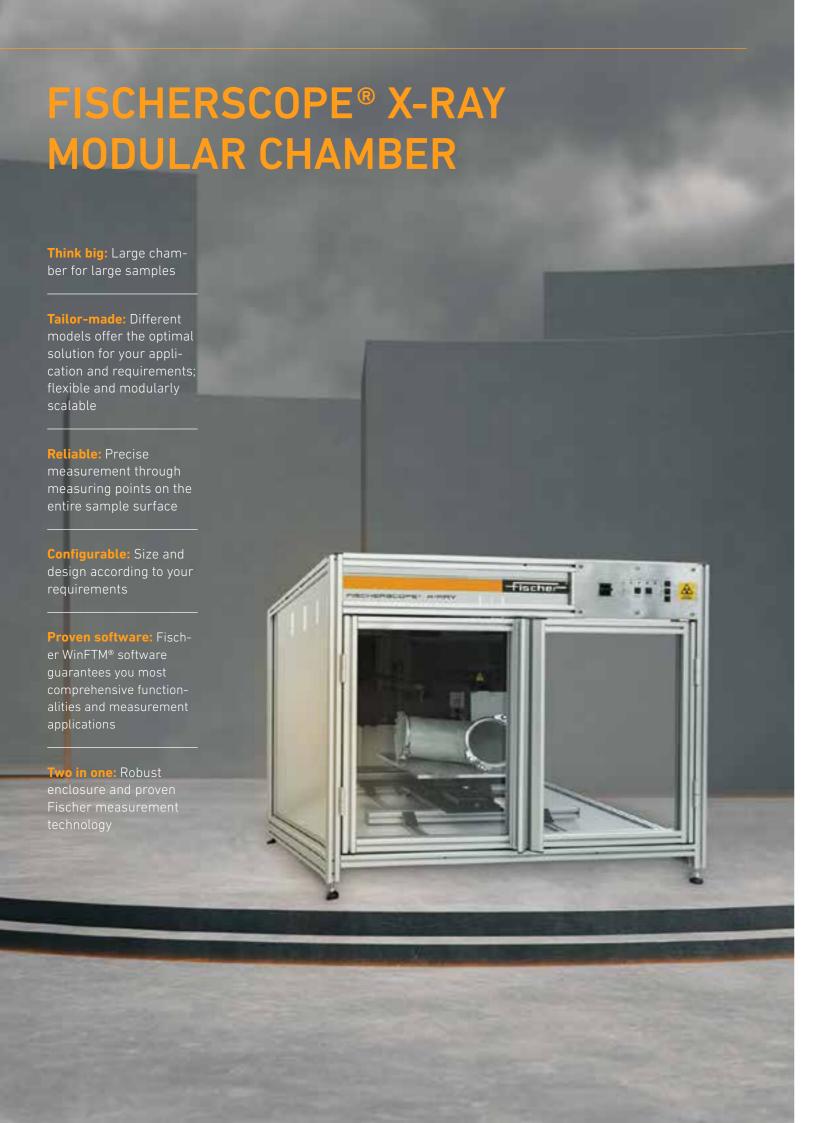


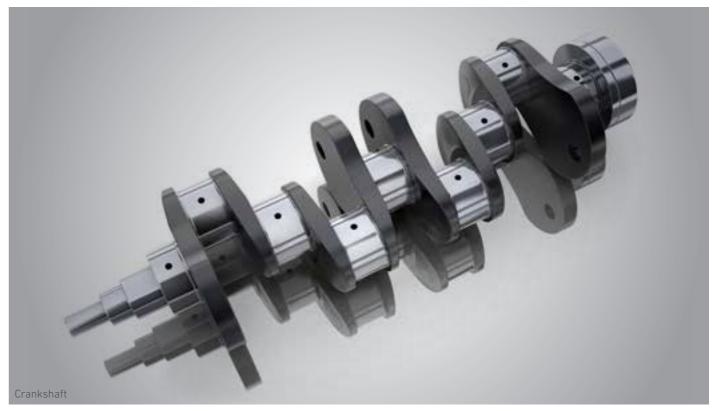
Measuring box

Measuring cell

Thanks to its three-point support, the XAN® 500 can be positioned securely on the surface, so layer thicknesses can be determined with repeatable accuracy. The results are shown directly on the display. For data evaluation, the handheld unit is equipped with the full version of WinFTM® software that is offered with all of Fischer's other X-ray systems. As calibration samples may not be readily available, the WinFTM®'s fundamental parameter analysis offers standard free measurement capabilities to measure without prior calibration.

- Mobile and universal handheld instrument for precise coating thickness measurement and material analysis – even with difficult material combinations
- Weight 1.9 kg
- Up to six hours operating time with one battery charge
- Portable measurement box transforms the system into a XRF benchtop instrument
- Air cooled mini X-ray tube
- Fixed aperture
- Measuring spot Ø3 mm
- Silicon drift detector for highest precision on thin layers
- Data evaluation via Bluetooth connection with full WinFTM® software
- Capable of bath analysis; liquid measuring cell is available option
- For outdoor use with IP54 protection rating





Measurements on large-volume samples

The Modular Chamber enables precise measurements and analysis on large-volume workpieces that exceed the sample sizes of Fischer's standard X-ray instruments. The Modular Chamber combines a large housing with Fischer's proven XRF measurement technology. You get the measurement technology of your choice mounted in a chamber customized for your needs. FISCHER-SCOPE® instruments of the XDL®, XDLM® and XDAL® series can be integrated.

The Modular Chamber offers maximum flexibility. Matching your sample, the support is available as a standard table or adapted support plate. The large, easily accessible measuring chamber allows convenient hand-ling of samples and can be configured in any size. The functional overall system comes with a stable underframe as an available option.

As standard, the chamber is equipped with metal sheets on the sides and Plexiglas panes in the front.



With underframe



Ideally suited for large samples up to 30 cm

- Large special enclosure for the integration of Fischer X-ray measurement technology for coating thickness measurements and material analysis on large-volume workpieces
- Integration of FISCHERSCOPE® X-RAY instruments XDL®. XDLM® and XDAL®
- Measuring direction with measuring top down
- Different X-ray tubes depending on the instrument
- Different apertures depending on the instrument
- Different filters depending on the instrument
- Various detectors ensure very good detection accuracy and high resolution: proportional counter tube, silicon PIN or silicon drift detector
- Different measuring table options: fixed or programmable
- Standard chamber size with approx. 1 m³ and 1.5 m³ or tailor-made





Inline measurement with utmost precision for thin layers

The FISCHERSCOPE® X-RAY 5000 is the perfect choice for non-destructive analysis and measurement of thin coatings on large-area products and substrates, such as in photovoltaics, fuel cells, on glass panels, films and tapes and very hot surfaces. The instruments of this series form modular units that can be easily integrated into manufacturing production lines. Their rugged design specifically meets the tough demands of industrial environments and for continuous operation.



FISCHERSCOPE® X-RAY 5100 Scanner



Simultaneous measurement by several FISCHERSCOPE® X-RAY 5100

Designed for automation, the measuring heads can be easily mounted on vacuum chambers via an ISO 250F flange or integrated inline in atmosphere. Calibration is quick and easy during the production process. With large apertures, state-of-the-art detectors and ultra-fast pulse processing, you benefit from excellent repeatability. The measuring heads can be integrated into existing lines or supplied as a complete customized turnkey solution.

- Robust inline instrument for analysis and measurement of thinnest layers and layer systems in the running process with connection to the production control system
- Microfocus tube with tungsten anode; molybdenum anode optional
- Fixed aperture (configurable up to Ø 11 mm)
- Fixed filter (configurable)
- Silicon drift detector 50 mm² for highest precision on thin layers as well as Peltier cooling
- DPP+ digital pulse processor for higher count rates and significantly reduced measurement times
- For measurements in vacuum or air
- Available option: Water cooling for sample temperatures up to 250 °C (482 °F)
- Any mounting position possible
- Remote control and data export via TCP/IP interface

FISCHERSCOPE® X-RAY 4000 Individually adaptable to your application Automatable: Approach measuring points precisely and change measuring task at the same time Inline measurement in real time: Precise and fast measurement in your shift operation Easy to operate: Strip for adjustment and operating panel easily accessible Compact design: Positioning axis and measuring head in one unit



Inline measurement with maximum endurance

The FISCHERSCOPE® X-RAY 4000 series is developed for the continuous and non-destructive analysis and measurement of layers and layer systems in manufacturing processes. Designed for industrial requirements, the inline measuring system is used in production sites for the measurement of electroplated layers on solid and stamped strips. It also works with formed and stamped contact surfaces and measures the electrical contacts on strip materials or on membranes for fuel cells.





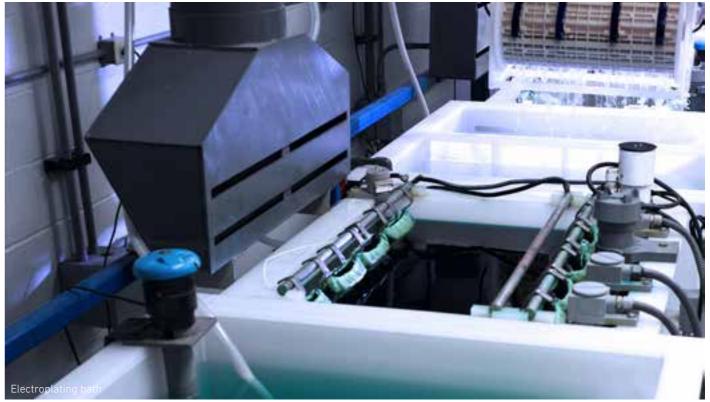
ped strip

FISCHERSCOPE® X-RAY 4200 (horizontal alignment)

Thanks to simple handling, automated calibration and minimum set-up times, converting from one product to another is simple due to the easily adjustable conveyor guides. The programmable axis of the measuring head allows reliable measurements at different positions of the product to be measured.

- Robust inline instrument for measurement on solid strips, stamped grids or coated membranes, from a few millimeters up to one meter wide
- Microfocus tube with tungsten anode; molybdenum anode optional
- 2-fold or 4-fold changeable apertures
- 6-fold changeable filter
- Silicon drift detector 50 mm² for highest precision on thin layers
- DPP+ digital pulse processor for higher count rates and significantly reduced measurement times
- Hardware and software aligned to measuring tasks related to inline measurement
- Horizontal or vertical installation position
- TCP/IP interface for process control





Efficient inline solution analysis for electroplating baths

With the FISCHERSCOPE® XAN® LIQUID ANALYZER you have your electroplating baths continuously in view – for an efficient control of your plating line. The high-precision inline measuring device enables the measurement of a wide range of metallic bath solutions, such as zinc, nickel, zinc/nickel, gold, palladium, chrome or even rhodium





Closed Loop System

Sophisticated and patented flow

Each electroplating bath has its own supply line to the respective measuring cell to prevent contamination. The low-maintenance device can be used flexibly in an industrial production environment as well as a complex multi-channel inline measuring system with full integration into a local production control system (MES). The device enables continuously accurate results 24/7. Measurement data is provided quickly, easily and in real time via fieldbus interface. The data is visualized, quickly recognizable, centrally at the device and at the control station or decentrally. The large touch display is easy and intuitive to operate. The measuring device is controlled via an integrated Siemens PLC.

Features

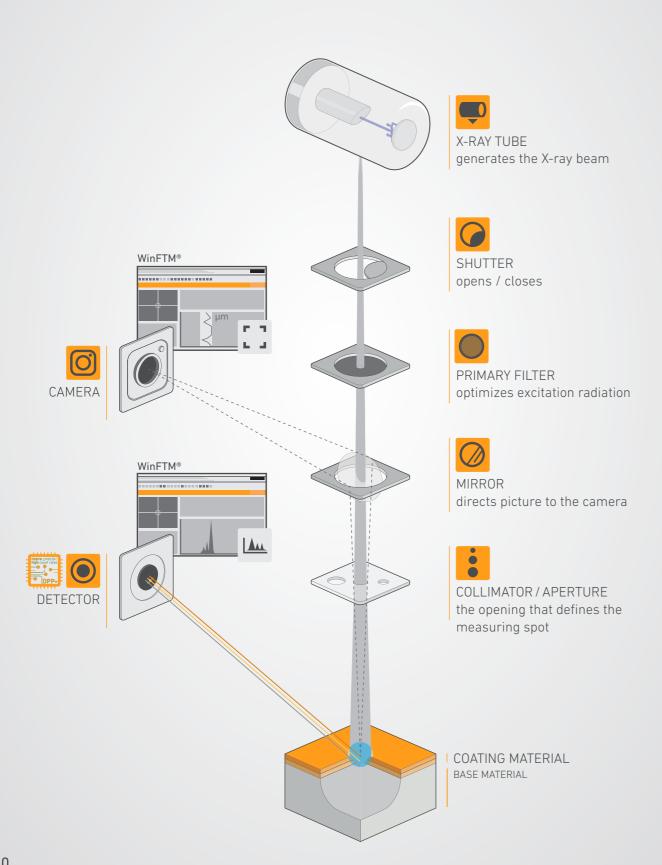
- Robust inline instrument for fully automated analysis of metal concentration in electroplating baths
- Automatic sequential measurement of up to 4 electroplating bath solutions (channels)
- 1-channel to 4-channel solution
- Microfocus tube with tungsten anode
- Silicon drift detector 50 mm² for highest precision
- Digital Pulse Processor DPP+ for minimizing measurement time and optimizing repeatability
- Fieldbus interface enables connection to higher-level control systems as well as equipment for equipment communication
- WLAN connectivity



VIDEO AND LANDING PAGE:

Scan the QR code and learn more about the FISCHERSCOPE® XAN® LIQUID ANALYZER.

Who wants to know exactly: The anatomy of the X-ray instrument



X-ray fluorescence analysis is a clean, non-contact, non-destructive and fast measurement method working for all elements of technical relevance. It is based on the phenomenon that atoms, when excited by primary X-rays, release energy in the form of element-specific fluorescence radiation. The spectrum of the emitted radiation provides information about the makeup of the sample. This enables both analysis of the material composition and measurement of a coating's thickness.



X-ray tube: The X-ray tube generates the primary X-ray radiation. More advanced models have a high-resolution microfocus tube. Devices thus equipped allow for smaller measuring spots.



Shutter: Integrated into the beam path, the shutter is a safety device. It prevents primary radiation from entering the measuring chamber. The system only unlocks for the duration of the measurement, and only when the lid is closed. This prevents the risk of harm to the operator.



Primary filter: Depending on the filter used, the excitation conditions can be adjusted for different measuring tasks.



Camera / Mirror: The mirror directs the image to the camera. This allows the positioning of the measuring spot to be monitored.



Collimator / Aperture: The aperture restricts the diameter of the primary beam, ensuring that a measuring spot of defined size is excited. With smaller apertures the majority of the primary radiation is shielded from the sample. Polycapillary optics, on the other hand, focus the entire X-ray radiation onto a tiny surface, allowing for short measuring times even with small measuring spots.



Detector: Its quality determines for which measuring tasks an instrument is suitable. Fischer offers three types of detectors:

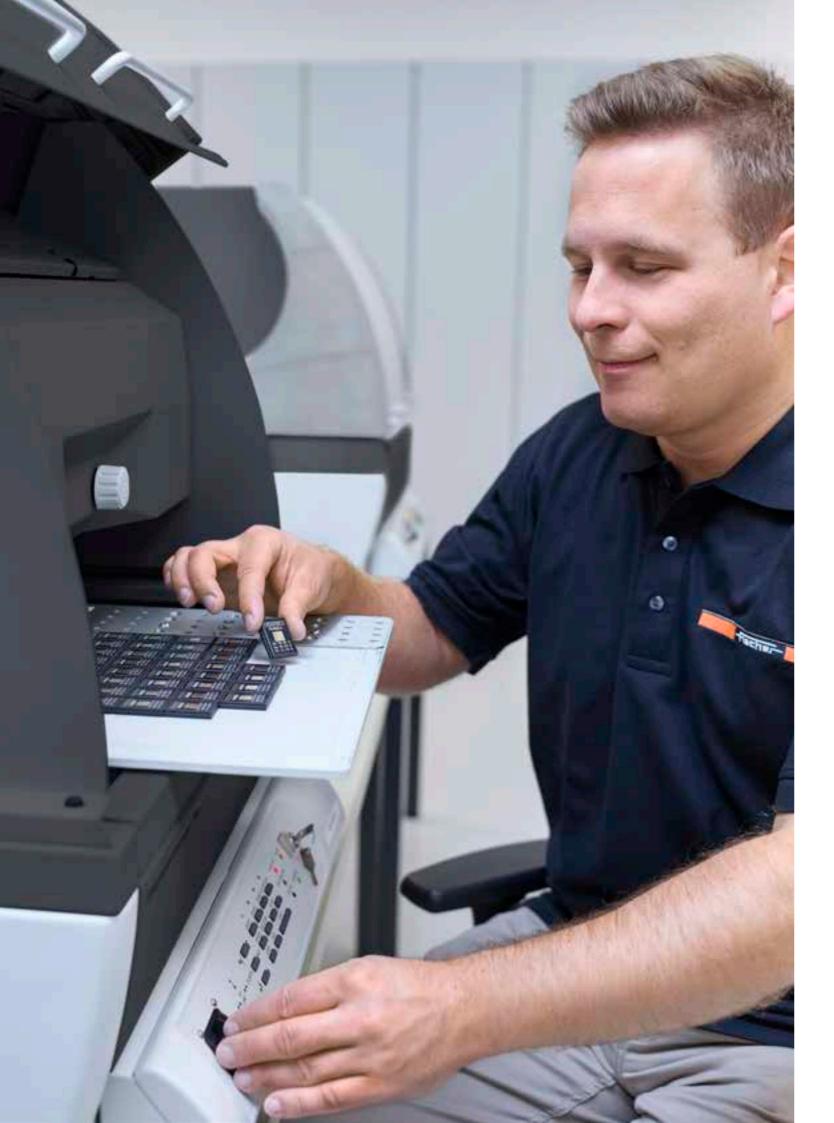
Proportional counter tube: The detector for simple measuring tasks is predestined for the measuring thicker layers with small measuring spots.

Silicon PIN diode (PIN): The mid-range detector can be used for both material analysis and coating thickness measurement of more complex measurement tasks.

Silicon drift detector (SDD): The strengths of this modern semiconductor detector lies in its ability to measure very thin layers and perform trace analysis in the ppm range.

Digital Pulse Processor (DPP): The in-house developed Fischer DPP is a high-tech component that processes very high pulse and counting rates. It amplifies the events recorded by the detector. Together with the detector, the DPP is responsible for very high stability and energy resolution. Regardless of the number of pulses per second.







Standards you can rely on

The right measurement is what counts

Only a well-calibrated measuring instrument delivers correct results. For this reason, Fischer relies on the highest accuracy for its calibration standards. Our inhouse calibration laboratories produce traceable calibration standards, also known as reference or comparison standards, which are recognized all over the world.

Whether coating thickness measurement, material analysis or material testing, with well over 500 different calibration standards, Fischer has the right standards for every application in its range. With prefabricated sets, for example for printed circuit boards, you are also ideally equipped for special tasks.

Calibration standards are foils or coated base material. Foil standards can be combined with other materials for further adherence to your measuring task.

Safety through our accredited test laboratory

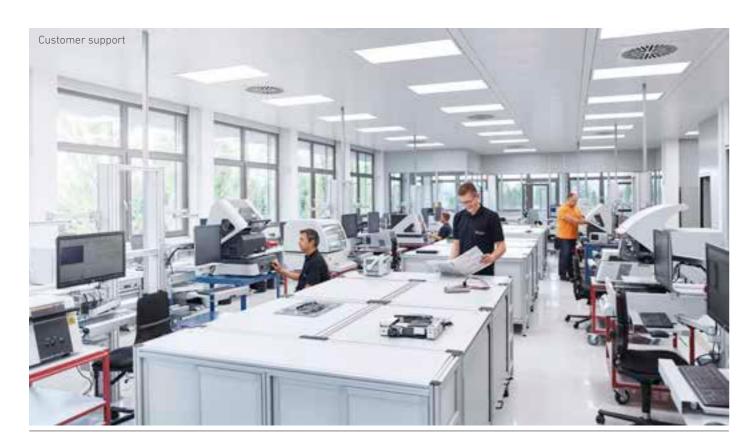
Fischer runs several accredited calibration laboratories worldwide. Our speciality: We are the first and only company with its own calibration laboratory in Germany that is accredited according to DIN EN ISO/IEC 17025

for the mechanical measurand "mass per unit area". By tracing the measurements back to national standards and thus to national metrology institutes such as the Physikalisch-Technische Bundesanstalt (PTB), National Institute of Standards and Technology (NIST) or National Institute of Metrology (NIM), the highest quality standards are achieved. Our internationally recognized calibration certificates and certificates of analysis give you and your products the necessary security and strengthen the confidence of your customers.

Unique service: your product as an individual calibration standard

Benefit from customized calibration standards by having your sample certified as a calibration standard by our measurement experts. In addition to in-house manufactured and certified standards, Helmut Fischer's calibration laboratory also offers ISO/IEC 17025 certification for specific customer material. So now you can use your workpieces for process control, quality control or development – all thanks to the calibration certificate!

Please feel free to contact us! We can advise you on suitable calibration standards and what calibration strategy to follow: sales@helmut-fischer.com



A reliable partner for the entire life of your instrument

All-around, worry-free package with maximum flexibility

For over 70 years, we have been there for our customers with outstanding products and unparalleled services. We attach just as much importance to fast and reliable service as we do to the quality of our products. As part of our 360° support, our service experts will assist you with the commissioning, inspection and maintenance of your equipment. With our training courses and product training, you will learn how to get the most out of your devices.

The advantages of regular inspections

To ensure that your instruments stay with you over a long period of time and provide reliable measured values, we recommend regular inspections – ideally on an annual basis. All inspections are carried out by our trained and experienced service personnel. Thanks to our worldwide support network, we can be flexibly deployed in your vicinity, enabling us to provide individual advice and onsite support with fast response times.

Through regular inspections, you extend not only the life of your device, but also keep your downtimes to a minimum. We plan your inspection times together with you

at an early stage and take your production schedule into account. To ensure that you remain able to measure, we are happy to provide you with a rental device to bridge any inspection or repair. The same applies to our spare parts: We only use original parts that are protected by our Fischer parts warranty.

In every respect, we are there for

- Telephone hotline and online support
- Regional service centers worldwide
- Onsite service in 21 countries
- Qualified X-ray service specialists
- Individual product training
- Customized inspection contracts
- Recertification and calibration service for reliable measurement results
- Individualized task programming
- Provision of rental equipment

At Fischer, the customer relationship does not end with the sale of an instrument – that is only when it begins.

Paul Comer, Technical Director at Graphic Plc, England

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Do you need technically sound advice? Please then contact us! sales@helmut-fischer.com



Everything concerning your measuring task

Application advice for precise measurement results

The formula for successful quality management is: the right measurement technology paired with the appropriate test method. These traits combined with the correct application of the equipment creates reliable, valid and controlled measurements. For all scientific and technical questions regarding your measuring task, our application laboratories are ready to assist you.

In seven application laboratories in Germany, Switzerland, China, USA, India, Japan and Thailand, specialists from physics, material science and engineering are available to provide you with advice and assistance. Whether helping to choose the right measuring instrument, developing an in-depth measuring strategy or defining the right measurement program. Especially when solving complex measuring tasks, you benefit from our comprehensive application consulting. This way, your employees always know what is important for the measurement.

Learn about our product portfolio onsite at one of our application laboratories. Our devices are also available there for you to test. All application laboratories are well connected, both among themselves and with universities, research and educational institutions as well as the

industry. This is how we make sure that the latest technology is available to you worldwide and how we ensure that we find the right answer to your question.

Our services at a glance

- Technical advice via e-mail, telephone and in person in the application laboratory
- Support in the application of measuring devices, e. g. operation, calibration and new measuring tasks
- Realization of feasibility studies on real parts to identify optimal measuring solutions
- Contract measurements with inspection report according to ISO 17025 (only in selected laboratories)
- Sample measurement live: We measure your sample and you participate live

Worldwide application consulting, also at your site



The answers to your application questions are always within arm's reach. Visit Fischer at one of our application laboratories or get local application support at your Fischer representative.

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- Authorized Distributor

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Our experienced staff will be happy to advise you locally and in your national language. Please find your personal contact at:

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